

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Satya, et al.

Attorney Docket No.: KLA1P016F/P642

Application No.: 09/648,095

Examiner: Quang D. Vu

Filed: August 25, 2000

Group: 2811

Title: CHEMICAL MECHANICAL POLISHING
TEST STRUCTURES AND METHODS
FOR INSPECTING THE SAME

AMENDMENT H

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully submitted that the Examiner enter the following amendments in response to the Office Action dated 27 March 2006, a response which is due 27 June 2006.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.